

# CHAPTER 18: ELECTRICAL PROPERTIES

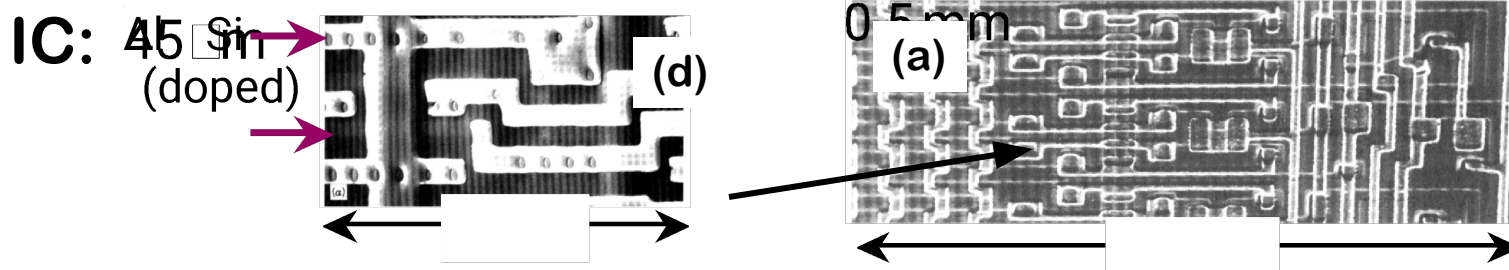
## ISSUES TO ADDRESS...

- How are electrical conductance and resistance characterized?
- What are the physical phenomena that distinguish conductors, semiconductors, and insulators?
- For metals, how is conductivity affected by imperfections,  $T$ , and deformation?
- For semiconductors, how is conductivity affected by impurities (doping) and  $T$ ?



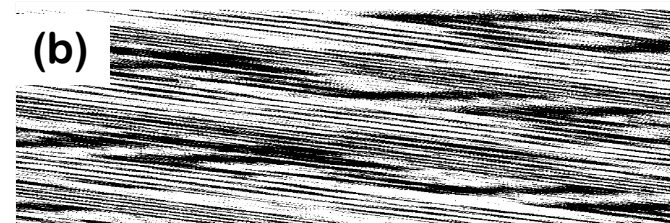
# VIEW OF AN INTEGRATED CIRCUIT

- Scanning electron microscope images of an



- A dot map showing location of Si (a semiconductor):

--Si shows up as light regions.



- A dot map showing location of Al (a conductor):

--Al shows up as light regions.



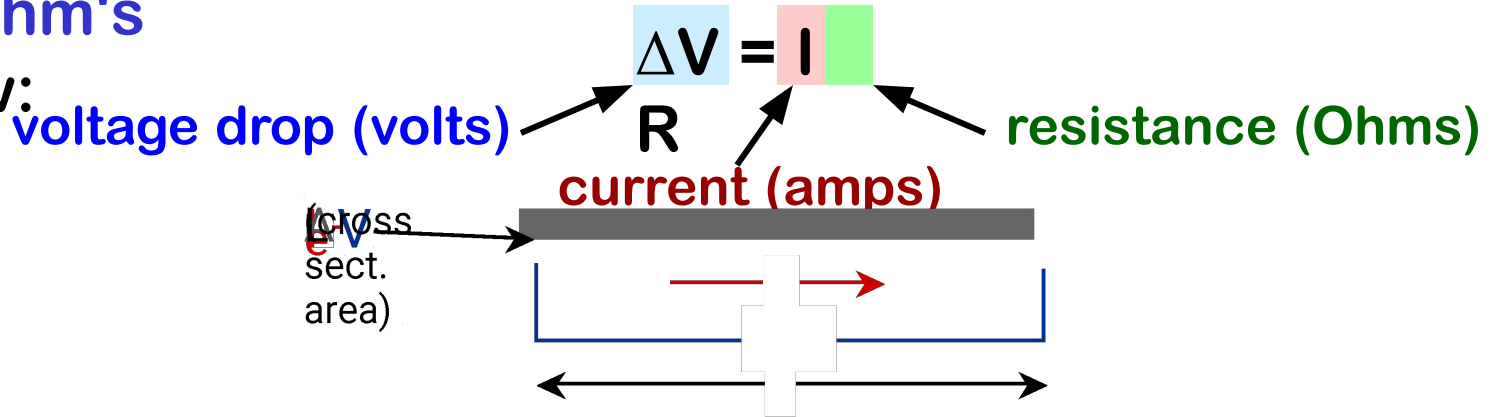
Fig. (d) from Fig. 18.25, *Callister 6e*. (Fig. 18.25 is courtesy Nick Gonzales, National Semiconductor Corp., West Jordan, UT.)

Fig. (a), (b), (c) from Fig. 18.0, *Callister 6e*.

# ELECTRICAL CONDUCTION

- Ohm's

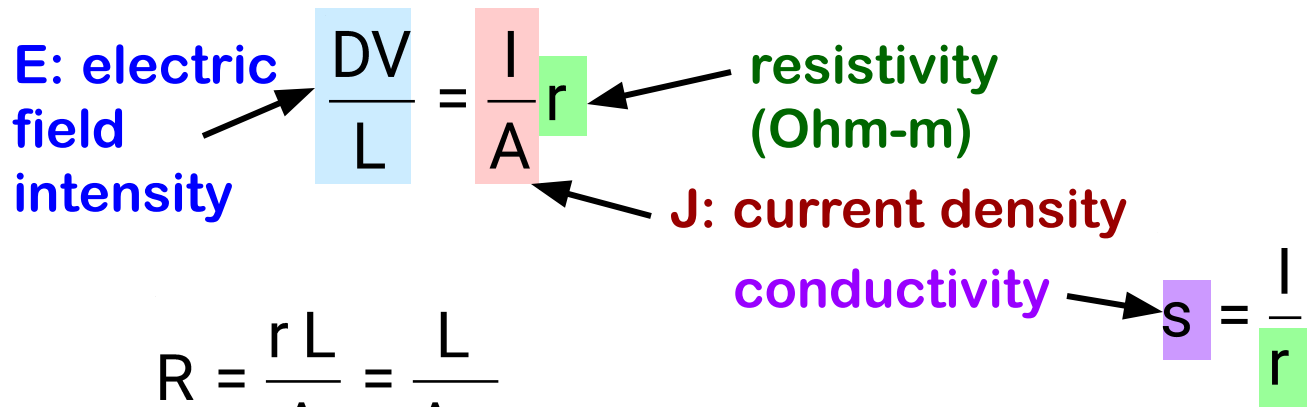
Law:



- Resistivity,  $\rho$  and Conductivity,  $\sigma$ :

--geometry-independent forms of Ohm's

Law



- Resistance:

$$R = \frac{rL}{A} = \frac{L}{As}$$

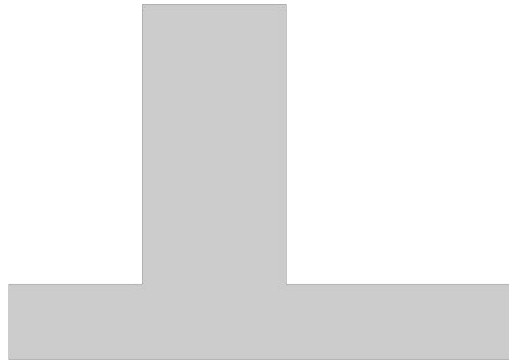
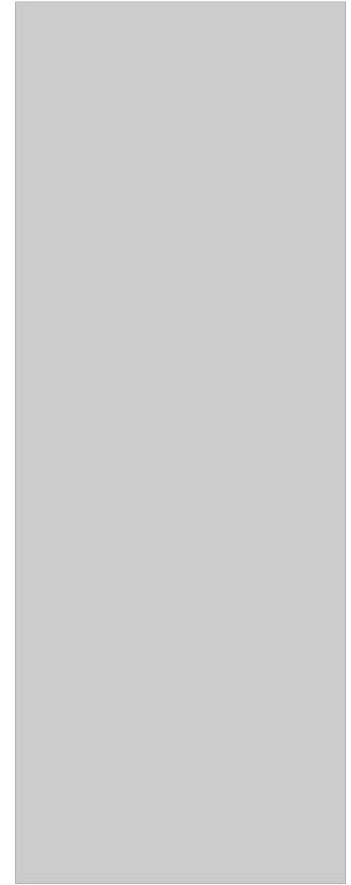


# CONDUCTIVITY: COMPARISON

- Room T values <sup>-1</sup>

(Quantities in  $10^{-17}$ )

|                            |       |
|----------------------------|-------|
| Quartz                     | $0.7$ |
| Aluminum nitride           | $1.0$ |
| Polymethyl methacrylate    | $1.0$ |
| Polystyrene                | $1.0$ |
| Polycarbonate              | $1.0$ |
| Polymethylsiloxane         | $1.0$ |
| Polysulfone                | $1.0$ |
| Polyethylene               | $1.0$ |
| Polypropylene              | $1.0$ |
| Polybutylene terephthalate | $1.0$ |
| Polyethylene terephthalate | $1.0$ |
| Polycarbonate              | $1.0$ |
| Polysulfone                | $1.0$ |
| Polymethylsiloxane         | $1.0$ |
| Polystyrene                | $1.0$ |
| Polymethyl methacrylate    | $1.0$ |
| Aluminum oxide             | $1.0$ |

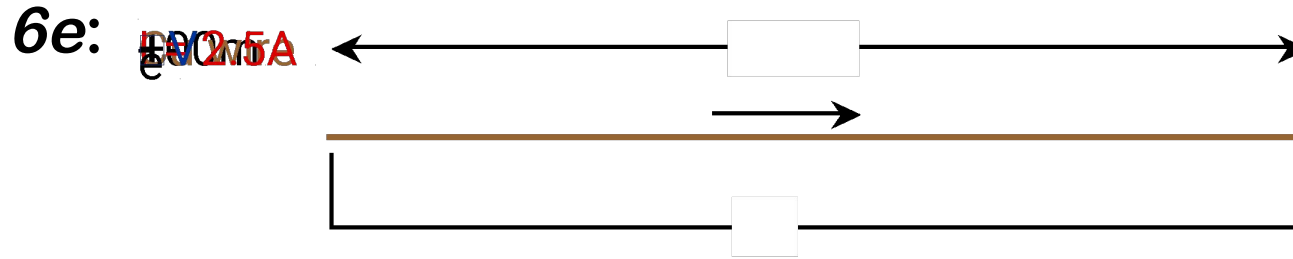


Selected values from Tables 18.1, 18.2, and 18.3, *Callister 6e*.



# EX: CONDUCTIVITY PROBLEM

- Question 18.2, p. 649, *Callister*



What is the minimum diameter (D) of the wire so that

$\Delta V < 1.5V?$

100m

$$R = \frac{L}{As} = \frac{DV}{I}$$

$< 1.5V$

$2.5A$

$6.07 \times 10^7$   
(Ohm-m)

$\frac{pD^2}{4}$

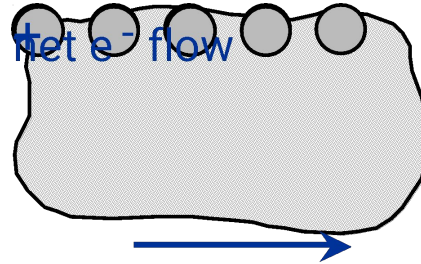
Solve to get  $D > 1.88$   
mm

-1



# CONDUCTION & ELECTRON TRANSPORT

- **Metals:**
  - Thermal energy puts many electrons into a higher energy state.
- **Energy States:**
  - the cases below for metals show that nearby energy states are accessible by thermal fluctuations.



# ENERGY STATES: INSULATORS AND SEMICONDUCTORS

- Insulators:

- Higher energy states not

- Semiconductors:

- Higher energy states separated by a smaller gap



# METALS: RESISTIVITY VS T, IMPURITIES

- Imperfections increase resistivity

- grain boundaries
- dislocations
- impurity atoms



These act to scatter electrons so that they take a less direct path.

- Resistivity increases

with:

- temperature
- wt% impurity
- %CW

$$r = r_{\text{thermal}}$$

$$+r_{\text{thermal}}$$

$$+r_{\text{def}}$$

Adapted from Fig. 18.8, *Callister 6e*. (Fig. 18.8 adapted from J.O. Linde, *Ann. Physik* 5, p. 219 (1932); and C.A. Wert and R.M. Thomson, *Physics of Solids*, 2nd ed., McGraw-Hill Book Company, New York, 1970.)





# EX: ESTIMATING CONDUCTIVITY

- ~~Q14~~ Estimate the electrical conductivity of a Cu-Ni

Adapted from Fig.  
7.14(b), *Callister 6e*.

$$r = 30 \times 10^{-8} \text{ Ohm} \cdot \text{m}$$

$$s = \frac{1}{r} = 3.3 \times 10^6 \text{ (Ohm} \cdot \text{m)}^{-1}$$

Adapted from Fig.  
18.9, *Callister 6e*.



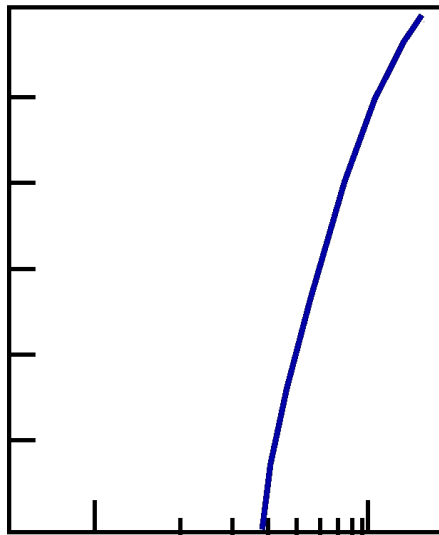
# PURE SEMICONDUCTORS: CONDUCTIVITY VS T

- Data for **Pure Silicon**:

$$\sigma_{\text{undoped}} \propto e^{-E_{\text{gap}} / kT}$$

-- $\sigma$  increases with T

500 Typical conductivity (undoped) (Ohm-m)<sup>-1</sup>



electrons  
can cross  
gap at  
higher T

| material | band gap (eV) |
|----------|---------------|
| Si       | 1.11          |
| Ge       | 0.67          |
| GaP      | 2.25          |
| CdS      | 2.40          |

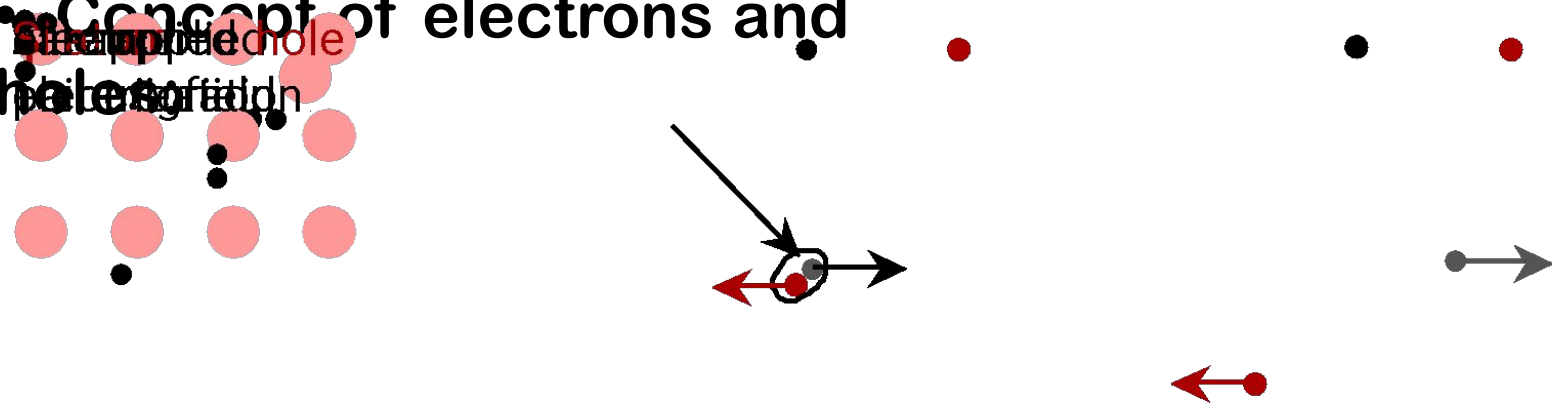
Adapted from Fig. 19.15, *Callister 5e*. (Fig. 19.15 adapted from G.L. Pearson and J. Bardeen, *Phys. Rev.* 75, p. 865, 1949.)

Selected values from  
Table 18.2, *Callister 6e*.



# CONDUCTION IN TERMS OF ELECTRON AND HOLE MIGRATION

• Concept of electrons and holes migration



• Electrical Conductivity given by:

$$s = n |e| m_e + p |e| m_h$$

# electrons/m<sup>3</sup>      # holes/m<sup>3</sup>      electron mobility      hole mobility

Adapted from Fig. 18.10, Callister 6e.

# INTRINSIC VS EXTRINSIC CONDUCTION

- Intrinsic:**

# electrons = # holes ( $n = p$ )

p)

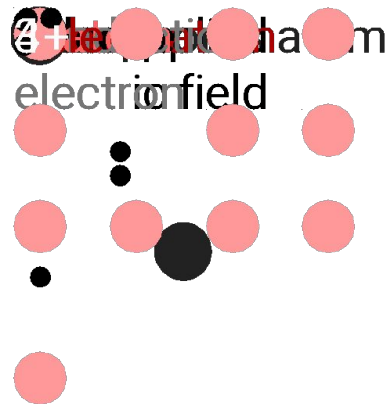
- Extrinsic:**

-- $n \neq p$

--occurs when impurities are added with a different

- N-type Extrinsic:** ( $n \gg p$ ) # valence electrons than the host (e.g., Si)
- P-type Extrinsic:** ( $p \gg n$ )

p)



n)



s a p | e | m\_h



# DOPED SEMICON: CONDUCTIVITY VS T

- Data for **Doped Silicon**:
  - $\sigma$  increases doping
  - reason: imperfection sites lower the activation energy to produce mobile electrons.
- Comparison: **intrinsic** vs **extrinsic** conduction...
  - extrinsic doping level:  $10^{21}/\text{m}^3$  of a n-type donor impurity (such as P).
  - for  $T < 100\text{K}$ : "freeze-out" thermal energy insufficient to excite electrons.
  - for  $150\text{K} < T < 450\text{K}$ : "extrinsic"
  - for  $T \gg 450\text{K}$ : "intrinsic"

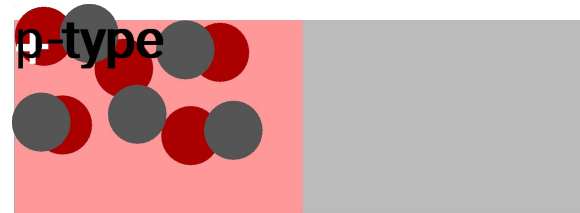
Adapted from Fig. 18.16, *Callister 6e*. (Fig. 18.16 from S.M. Sze, *Semiconductor Devices, Physics, and Technology*, Bell Telephone Laboratories, Inc., 1985.)

Adapted from Fig. 19.15, *Callister 5e*. (Fig. 19.15 adapted from G.L. Pearson and J. Bardeen, *Phys. Rev.* 75, p. 865, 1949.)

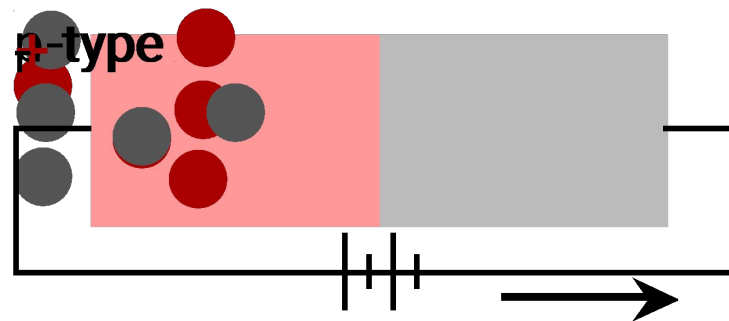
# P-N RECTIFYING JUNCTION

- Allows flow of electrons in one direction only (e.g., useful to convert alternating current to direct current).
- Processing: diffuse P into one side of a B-doped crystal.

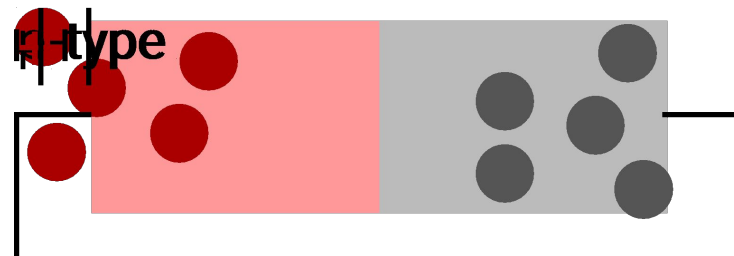
• **Results:**  
 --No applied potential:



--no net current flow  
 --Forward bias: carrier flow through p-type and n-type regions; holes and electrons recombine at p-n junction; current flows.



--Reverse bias: carrier flow away from p-n junction; carrier conc. greatly reduced at junction; little current flow.



# SUMMARY

- Electrical **conductivity** and **resistivity** are:
  - material parameters.
  - geometry independent.
- Electrical **resistance** is:
  - a geometry and material dependent parameter.
- **Conductors, semiconductors, and insulators...**
  - different in whether there are accessible energy states for conductance electrons.
- **For metals, conductivity is increased by**
  - reducing deformation
  - reducing imperfections
  - decreasing temperature.
- **For pure semiconductors, conductivity is increased by**
  - increasing temperature
  - doping (e.g., adding B to Si (p-type) or P to Si (n-type))



# ANNOUNCEMENTS

Reading:

Core  
Problems:

Self-help  
Problems:

